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Docket No.: M-12467 US

**Box Patent Application
Commissioner For Patents
Washington, D. C. 20231**

January 24, 2002

Enclosed herewith for filing is a patent application, as follows:

Inventor: Renken, Wayne

Title: PROCESS CONDITION SENSING WAFER AND DATA ANALYSIS SYSTEM

<u>X</u>	Return Receipt Postcard
<u>X</u>	This Transmittal Letter (in duplicate)
<u>13</u>	page(s) Specification (not including claims)
<u>7</u>	page(s) Claims
<u>1</u>	page Abstract
<u>10</u>	Sheet(s) of Drawings
<u>1</u>	page NonPublication Request

☒ Applicant asserts entitlement to small entity status for the attached patent application

CLAIMS AS FILED (fees computed under 37 CFR §1.9(f))

[illegible]

Please make the following charges to Deposit Account 19-2386:

- ☒ Total fee for filing the patent application in the amount of \$ 595.00
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account 19-2386.

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Respectfully submitted,

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